

Docket No.: 21302/0204309-US0

(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Euijoon Yoon *et al.*

Application No.: 10/596,126

Confirmation No.: 2554

Filed: May 31, 2006

Art Unit: 2813

For: GROWTH METHOD OF NITRIDE
SEMICONDUCTOR LAYER AND LIGHT
EMITTING DEVICE USING THE GROWTH
METHOD

Examiner: Crawford, LaTanya N.

MS Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

March 10, 2010

INTRODUCTORY COMMENTS

Dear Sir:

In response to the Non-Final Office Action dated December 16, 2009, please amend the above-identified U.S. patent application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 7 of this paper.